

Special Issue

Emerging Smart Materials for Microelectromechanical Systems

Message from the Guest Editor

The development of functional and multifunctional materials for the application of microelectromechanical systems (MEMS) is needed to enhance performance and create new transduction mechanisms for sensors and actuators. Enhancing material properties and developing methods of integrating and fabricating materials is the cornerstone to developing new MEMS devices. Accordingly, this Special Issue seeks to showcase research papers, short communications, and review articles that focus on the development of emerging functional and multifunctional materials for MEMS devices. This includes, but is not limited to, the development of new materials, enhancing material properties, developing new transduction mechanisms for materials, the integration of materials, new deposition techniques, or increasing manufacturing compatibility with MEMS. The Special Issue is interested in all types of functional materials, including 2D and thin films.

Guest Editor

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